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John H.

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I hereby certify that this correspondence is being
mailed by first class mail with sufficient postage to
Assistant Commissioner for Patents
Washington D.C. 20231, on: December 26, 2002.

Robert Moll
Robert Moll

U.S. PATENT AND TRADEMARK OFFICE

In re Application of: McDonald Robinson
et al.

Examiner: Timothy J. Sutton
Art Unit: 2813

Title: Methods of Using Si-Ge-C in Selective
Etch Applications

Attorney Docket No. Lawrence 712

Application No. 10/010,704

Filing Date: November 13, 2001

AMENDMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Examiner Sutton:

In response to the Office action dated August 26, 2002, please extend the time for
response by one month in accordance with the enclosed petition, enter this amendment
and consider the following remarks.

01/03/2003 CCHAU1 00000127 10010704

03 FC:1202 360.00 OP
04 FC:1201 168.00 OP

Adjustment date: 01/30/2003 ASMITH
01/03/2003 CCHAU1 00000127 10010704
03 FC:1202 -360.00 OP
04 FC:1201 -168.00 OP

01/30/2003 ASMITH 00000001 10010704
01 FC:1202 108.00 OP
02 FC:1201 420.00 OP